



Docket No.: H6808.0004/P004  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Atsushi Takane, et al.

Examiner: Phillip A. Johnston

Application No.: 10/082,286

Art Unit: 2881

Filed: February 26, 2002

For: SEMICONDUCTOR INSPECTION SYSTEM

**AMENDMENT**

Commissioner for Patents  
MS: Amendment  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This paper is in response to the non-final Office Action dated April 20, 2005.  
Please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 10 of this paper.